

Bill Blackwood Law Enforcement Management Institute of Texas



Fire Executive Management Training

Fire Marshal Professional Development Program Class #10

Application for Admission

Applications are now being accepted. Admission to the FEMT program is competitive and applications are ranked on completion and when they are received (date-stamped). The cost of each module (due by the 1st day of that module) is \$1000 and includes the following:

- Registration & class materials
- FEMT Shirt
- Lunch daily

- One evening meal
- Hotel (including breakfast) 5 nights
- Parking

Instructions for completing this application

Your application should include the following:

- · This form, completed in its entirety
- · Copies of all necessary certificates, letters, etc.
- Resume

Please email all documents to <u>femt@shsu.edu</u>. If you have any questions, you may call Angelica France at 936-294-1670. A notification email will be sent to you to indicate receipt of your application.

Personal Information

Last Name	First Name		Preferred Na	me
Middle Initial Date of	Birth	PID#	Gender:	Male
Ethnicity: • African Ame	rican • Asian	Hispanic	Native American	• White • Other
Rank/Title (Chief, Fire Marsl	nal, Deputy FM, etc.)			
Agency Name		_ Agency Ad	ldress	
City	State	_ County		Zip
Cell Phone		Preferred	Phone	
Work Email				
 include those throug (Please submit the attention of the property of	as a fire inspector, fire h TCFP, IFSAC, Propropriate document ointment as a fire mander of verification from y supervisory role with least one of the follow	e investigator Board, SFFM .) rshal. rour jurisdiction OR n my agency a wing: er II, or propriate field	or public educator. An An ICC, or NFPA. In or governing body.) Indirequest a waiver from the or governing body.	cceptable certifications
Resume		,	,	
Please submit a complete p Applicant's Staten I understand that, if selected required to attend the entire	nent of Comm	arshal Profes		rogram, I will be
Applicant Signature			Date Signed	

We appreciate your interest in this program and the dedication it took to submit this application.